I hereby certify that this correspondence is being deposited with the U.S. Postal Service with sufficient postage as First Class Mail in an envelope addressed to: MS Amendment, Commissioner for Patents, P.O. Box 1 50, Alexandria, VA 2313-1450, on the date shown below.

Docket No.: 29936/39485

(PATENT)

IN THE UNITED STAT PATENT AND TRADEMARK OFFICE

in re Patent Application of:

Kwan Y. Lim et al.

Application No.: 10/615,478

Art Unit: 2829

Filed: July 8, 2003

Examiner: Not Yet Assigned

For: METHOD OF FORMING GATE IN

SEMICONDUCTOR DEVICE

AMENDMENT IN RESPONSE TO NON-FINAL OFFICE ACTION

MS Amendment **Commissioner for Patents** P.O. Box 1450 Alexandria, VA 22313-1450

Dear Sir:

INTRODUCTORY COMMENTS

In response to the Office Action dated July 14, 2004, please amend the aboveidentified U.S. patent application as follows:

Amendments to the Specification begin on page 2 of this paper.

Amendments to the Claims are reflected in the listing of claims which begins on page 8 of this paper.

Remarks/Arguments in support of the allowability of this application begin on page 12 of this paper.